

## Electronic Patent Application Fee Transmittal

Application Number:	10595640
Filing Date:	02-May-2006
Title of Invention:	Transistor and cvd apparatus used to deposit gate insulating film thereof
First Named Inventor/Applicant Name:	Toshihide Tsubata
Filer:	Christopher Andrew Bennett/Sonia McVean
Attorney Docket Number:	70404.90/ma

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 1 month with \$0 paid	1251	1	120	120

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>120</b>